



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 3756

Tomohiro OKUMURA et al.

Docket No. 00177/530809

Serial No. 09/511,398

Group Art Unit 1762

Filed February 23, 2000

Examiner M. Padgett

PLASMA PROCESSING METHOD  
AND APPARATUS

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents,  
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of September 20, 2002.

The fee of \$930.00 is

submitted herewith.

to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

Small entity status of this application is established by a Small Entity Status Assertion which

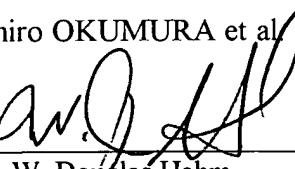
is enclosed.

has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By

  
W. Douglas Hahm

Registration No. 44,142  
Attorney for Applicants

WDH/gtg

Washington, D.C. 20006-1021

Telephone (202) 721-8200

Faxsimile (202) 721-8250

March 20, 2003

RECEIVED  
MAR 24 2003  
TC 1700